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PATENT
60303.45

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re. application of : Mitsutoshi NATSUMEDA and Hirofumi TAKABAYASHI Serial No.: Unknown Filed: Concurrently herewith For: MAGNETIC FIELD ANALYZING METHOD AND DEVICE THEREFOR	International Application No.: PCT/JP2003/012558 International Filing Date: September 30, 2003
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INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Applications
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with 37 CFR §1.56, and in recognition of their duty to disclose to the United States Patent and Trademark Office relevant information known to be material to patentability, Applicants herewith submit copies of the prior art listed on the attached Information Disclosure Statement (Form PTO-1449). The prior art reference 1 was cited in the International Search Report for PCT application No. PCT/JP2003/012558. The prior art references 2-5 are additional references that Applicants submit herewith. Applicants submit herewith an English abstract and a machine translation for the prior art references 1-4. The relevance of prior art reference 5 is discussed on page 2, lines 7-11 of the originally filed specification.

The statement is not a representation that all of the information cited is necessarily effective as prior art against the application.

International Application No.: PCT/JP2003/012558
U.S. Patent Application No.: Unknown
July 16, 2004
Page 2 of 2

Applicants respectfully request that the disclosed references be made of record
in the subject application.

Respectfully submitted,

Date: July 16, 2004


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Sheet	1	of	2
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Filing Date

First Named Inventor

Art Unit

Examiner Name

Mitsutoshi NATSUMEDA

Attorney Docket Number	60303.45
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Page	Column	Line	Where Relevant Passages or Relevant Figures Appear
1	1	1-2	1-2
1	1	3-4	3-4
1	1	5-6	5-6
1	1	7-8	7-8
1	1	9-10	9-10
1	1	11-12	11-12
1	1	13-14	13-14
1	1	15-16	15-16
1	1	17-18	17-18
1	1	19-20	19-20
1	1	21-22	21-22
1	1	23-24	23-24
1	1	25-26	25-26
1	1	27-28	27-28
1	1	29-30	29-30
1	1	31-32	31-32
1	1	33-34	33-34
1	1	35-36	35-36
1	1	37-38	37-38
1	1	39-40	39-40
1	1	41-42	41-42
1	1	43-44	43-44
1	1	45-46	45-46
1	1	47-48	47-48
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1	1	67-68	67-68
1	1	69-70	69-70
1	1	71-72	71-72
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1	1	75-76	75-76
1	1	77-78	77-78
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1	1	81-82	81-82
1	1	83-84	83-84
1	1	85-86	85-86
1	1	87-88	87-88
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1	1	93-94	93-94
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1	1	131-132	131-132
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1	1	143-144	143-144
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1	1	149-150	149-150
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1	1	163-164	163-164
1	1	165-166	165-166
1	1	167-168	167-168
1	1	169-170	169-170
1	1	171-172	171-172
1	1	173-174	173-174
1	1	175-176	175-176
1	1	177-178	177-178
1	1	179-180	179-180
1	1	181-	

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